Ar/2815/A

03500.016133

#### PATENT APPLICATION

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

h re Application of:	)
TADAYOSHI MUTA,	: Examiner: Eugene Lee
Application No.: 10/052,450	: Group Art Unit: 2815
Filed: January 23, 2002	; )
For: SEMICONDUCTOR DEVICE, PRODUCTION METHOD THEREFOR, AND ELECTROPHOTOGRAPHIC APPARATUS	) : ) November 23, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **INFORMATION DISCLOSURE STATEMENT**

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the foreign patent documents, together with English-language abstracts, are enclosed.

The listed documents were cited in a Office Action in a corresponding Korean application. A copy of the Office Action, which is dated September 23, 2004, is enclosed.

According to a commercial database, U.S. Patent No. 6,252,777 is in the same family as Korea 2001-0006162.

11/24/2004 LWDNDIM1 00000057 10052450

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# STATEMENT UNDER 37 C.F.R. § 1.97(e)

Each item of information in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

## FORMAL MATTERS

We also enclose a check for \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. § 1.97(d)(2). Any overpayment should be credited and any deficiency should be charged to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.

## **CONCLUSION**

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Damond E. Vadnais Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

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FORM PTO 1449 (modified)  J.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(9) (Use several sheets if necessary)		ATTY DOCKET NO. 03500.016133		APPLICATION NO. 10/052,450		
		APPLICANT TADAYOSHI MUTA				
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*EXAMINER	DOCUMENT	NOT S	U.S. PATENT DOCUMENTS			FILING DATE
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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	6-310324	11/04/1994	Japan			Abstract
	2001-0006162	01/26/2001	Korea			Abstract
		OTHER DOCUMENT	S) (Including Author, Title, Date, Pertine	int Pages Etc.)		
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.